

	L #	Hits	Search Text	DBs	Time Stamp
1	L1	2450	(427/523-531).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 15:58
2	L2	3667	((427/576,564) or (204/192.15,192.16,192. 38)).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 15:58
3	L3	1149	(L1 or L2) and (DC "D.C." direct adj current) and (RF "R.F." (radio high low) adj frequency HF "H.F." alternating adj current AC "A.C.")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 15:59
4	L4	349	L3 and ((ion plasma) adj plat\$4 or bias\$4 adj (substrate piece peice work workpeice workpiece holder object article))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 16:00
5	L5	190	L4 and (filament coil basket)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 16:01
✓ 6	L6	139	L4 and (filament coil basket)with(source depositant evaporant deposition target)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 16:03

02/427,775

	L #	Hits	Search Text	DBs	Time Stamp
✓ 7	L7	51	L5 not L6	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 16:03
✓ 8	L8	159	L4 not (L6 or L5)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/03/20 16:04